



PATENT

Case Docket No. ASMMC.036AUS

Date: January 10, 2003

Page 1

#10
Dups. Change
D. Smith's log
1-2903

In re application of : Sophie et al.
App. No. : 09/975,466
Filed : October 9, 2001
For : IN SITU REDUCTION OF
COPPER OXIDE PRIOR TO
SILICON CARBIDE
DEPOSITION
Examiner : Kielin, E.
Art Unit : 2813

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(Date)

Adeel S. Akhtar, Reg. No. 41,394

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Sir:

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated as shown below:

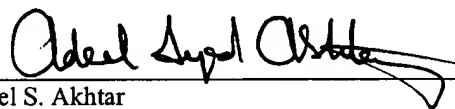
CLAIMS AS FILED

	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
Total Claims	21	32	= 0 ×	\$18	= \$0
Independent Claims	2	4	= 0 ×	\$84	= \$0
If application has been amended to contain multiple dependent claim(s), then add				\$280	= \$0
Time Extension Fee					\$0
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0

- (X) Amendment and Response to Office Action in 6 pages.
- (X) Corrected Drawings in 9 pages.
- (X) An Information Disclosure Statement.
- (X) A PTO Form 1449 with references.

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